

WEST Search History

DATE: Friday, August 15, 2003

Set Name Query

side by side

Hit Count Set Name

result set

DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

L5	L4 and l1	10	L5
L4	L2 same (substrate or wafer or semiconductor)	61	L4
L3	L2 and l1	109	L3
L2	(clean\$3 or etch\$3 or wash\$3 or rins\$3) same nozzle\$3 same transvers\$3	1928	L2
L1	((134/21 134/34 134/36 134/37 134/902 134/94.1 134/99.1 134/103.2 134/172 134/198)!.CCLS. (216/92)!.CCLS. (438/906)!.CCLS. (156/345.15 156/345.54 156/345.11 156/345.17 156/345.21 156/345.23)!.CCLS.)	7818	L1

END OF SEARCH HISTORY